



ELECTRONIC COPY

LG767612582
Report verification at igi.org



January 21, 2026

IGI Report Number **LG767612582**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **10.26 - 10.30 X 6.07 MM**

GRADING RESULTS

Carat Weight **3.97 CARATS**

Color Grade **E**

Clarity Grade **VS 2**

Cut Grade **EXCELLENT**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

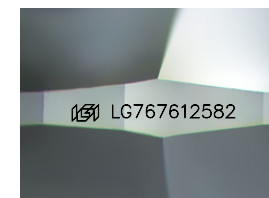
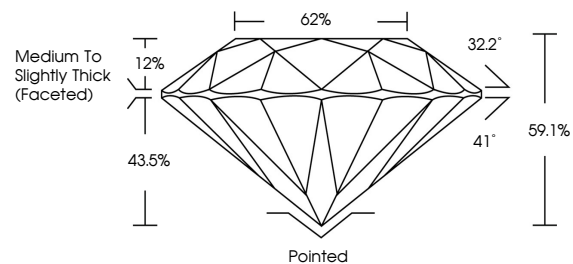
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG767612582**

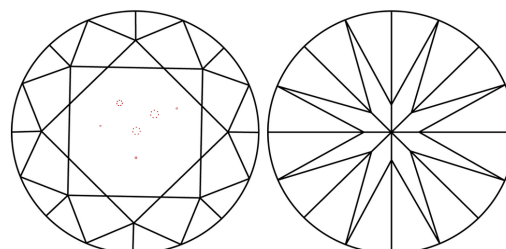
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

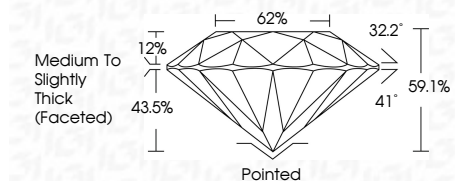
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

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Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



January 21, 2026
IGI Report No LG767612582
ROUND BRILLIANT

3.97 CARATS
E
VS 2
EXCELLENT
62%
Medium To Slightly Thick (Faceted)

Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG767612582

Cutlet
Polish
Symmetry
Fluorescence
Inscriptions(s)

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